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**Innovativity To Productivity**

**PRODUCTIVE TECHNOLOGIES COMPANY LIMITED**

**普達特科技有限公司\***

*(Incorporated in Bermuda with limited liability)*

**(Stock Code: 650)**

## **UPDATE ON DEVELOPMENT OF EQUIPMENT FOR SEMICONDUCTOR AND SOLAR POWER**

This announcement is made by Productive Technologies Company Limited (the “**Company**”) on a voluntary basis to keep the shareholders and potential investors of the Company informed of the latest business development of the Company.

Reference is made to the announcement of the Company dated 29 May 2023 in relation to the development of the equipment for semiconductor and solar power (the “**Announcement**”). Unless the context requires otherwise, the capitalized terms contained herein will have the same meanings as those defined in the Announcement.

### **SHIPMENT OF SEMICONDUCTOR WET CLEANING EQUIPMENT OF OCTOPUS PLATFORM**

The Board is pleased to announce that on August 10, 2023, the Company completed the shipment of the semiconductor wet cleaning equipment of OCTOPUS platform (the “**Product**”) to its customer. The revenue from the equipment order is yet to be recognized. To the best of the Directors’ knowledge, information, and belief, having made all reasonable inquiries, the customers and their ultimate beneficial owners are third parties independent of the Company and its connected persons as of the date of this announcement.

The OCTOPUS wet processing platform is equipped with 16 chambers and is suitable for customers with large volume production needs and seeking maximum WPH (wafer per hour). The chamber and chemical solution supply system of the OCTOPUS platform equipment adopts a vertical plane array layout, which provides high production capacity and optimal chemical solution recycling efficiency, thereby reducing chemical consumption costs for customers.

The OCTOPUS platform offers a wide range of Chuck configurations for customized wafer cleaning, double-sided cleaning, bevel cleaning and etching requirements. OCTOPUS platform can be used to increase production capacity with multiple chambers in a single application, or be configured for different applications on the same platform to meet varying research and development needs.

The Product is a piece of single-wafer cleaning equipment designed for applications in silicon wafer cleaning that removes any adhering particles and organic/inorganic impurities.

## **GENERAL**

The transaction contemplated under the equipment order does not constitute notifiable transaction of the Company under Chapter 14 of the Rules Governing the Listing of Securities on The Stock Exchange of Hong Kong Limited. The Company will make further announcement(s) as and when appropriate if required.

**The Shareholders and potential investors are advised to exercise caution when dealing in the securities of the Company.**

By Order of the Board  
**Productive Technologies Company Limited**  
**Liu Erzhuang**  
*Chairman and Chief Executive Officer*

Hong Kong, 10 August 2023

*As at the date hereof, the Board comprises seven Directors, of whom three are executive Directors, namely Dr. Liu Erzhuang (Chairman), Mr. Tan Jue and Mr. Liu Zhihai; one is non-executive Director, namely Mr. Cao Xiaohui; and three are independent non-executive Directors, namely Ms. Ge Aiji, Mr. Chau Shing Yim David, and Mr. Wang Guoping.*

\* *For identification purposes only*